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Sheet 1 of

Complete if Known					
Application Number	09/902,902				
Filing Date	07/29/2001				
First Named Inventor	Stephen C. Baer				
Group Art Unit	2838				
Examiner Name					
Attorney Docket Number					

## U.S. PATENT DOCUMENTS

				U.S. PATENT DOCU	MENTS	
Examiner Initials*	Cite No. <sup>1</sup>	Number (ii	ument nd Code² ' <i>known</i> )	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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				FORE	IGN PATENT DOCUMENTS	S		
Examiner	Cite	<u> </u>	Foreign Patent Doo		Name of Patentee or	Date of Publication of	Pages, Columns, Lines, Where Relevant	T
Initials*	No.1	Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)	Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T6
010		FR	2,613,845		Maureau et al.	10/1984		
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Signature	Jack Berman	Considered	1/30/03
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## **INFORMATION DISCLOSURE** STATEMENT BY APPLICANT

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Compl te if Known				
Application Number	09/902,902			
Filing Date	07/29/2001			
First Named Inventor	Stephen C. Baer			
Group Art Unit	2838			
Examiner Name				
Attorney Docket Number				

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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3 of 3

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Application Number	09/902,902					
Filing Date	07/29/2001					
First Named Inventor	Stephen C. Baer					
Group Art Unit	2838					
Examiner Name						
Attorney Docket Number						

		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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Signature Guy Considered Considered	Examiner Signature	Jack Berman	Date Considered	7/30/03
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